Message Text

UNCLASSIFIED

PAGE 01 TOKYO 02595 230421Z

63

ACTION COME-00

INFO OCT-01 EA-09 ISO-00 EB-07 /017 W $\,$

----- 083701

R 230415Z FEB 76

FM AMEMBASSY TOKYO

TO SECSTATE WASHDC 7072

UNCLAS TOKYO 2595

FOR: U.S. PATENT COMMISSIONER, C. MARSHALL DANN FROM AMBASSADOR

E.O. 11652: N/A TAGS: EGEN, JA

SUBJECT: PROPOSED VISIT OF JAPANESE STUDY GROUP TO U.S.

PATENT OFFICE

- 1. I UNDERSTAND THE JAPANESE INSTITUTE OF INVENTION AND INNOVATION WROTE TO YOU JAN. 28 INQUIRICNG WHETHER ITS STUDY GROUP MAY CALL ON U.S. PATENT OFFICE MAR. 10 AND 11 TO DISCUSS HOW U.S. PATENT OFFICE HANDLES PRINTING, PUBLISHING AND DISTRIBUTION OF INDUSTRIAL PORPERTY LITERATURE AND RELATED PROBLEMS. THE INSTITUTE HAS WRITTEN TO ME UNDER DATE OF FEB. 12 TO REQUEST EMBASSY'S SUPPORT OF ITS MISSION.
- 2. I HOPE IT WILL BE POSSIBLE FOR THE U.S. PATENT
 OFFICE TO RECEIVE THIS GROUP AND RENDER IT EVERY
 APPROPRIATE ASSISTANCE. THE GROUP, WHICH INCLUDES
 MR. HIDEO SAITO, FORMER DIRECTOR GENERAL OF THE
 JAPANESE PATENT OFFICE, CONSISTS MAINLY OF PRIVATE
 INDUSTRIAL EXPERTS CONCERNED WITH PATENT DOCUMENTATION.
 HODGSON

UNCLASSIFIED

NNN

Message Attributes

Automatic Decaptioning: X Capture Date: 01 JAN 1994 Channel Indicators: n/a

Current Classification: UNCLASSIFIED

Concepts: VISITS, PATENTS Control Number: n/a Copy: SINGLE Draft Date: 23 FEB 1976 Decaption Date: 01 JAN 1960 Decaption Note: Disposition Action: n/a Disposition Approved on Date: Disposition Authority: n/a Disposition Case Number: n/a

Disposition Case Number: n/a
Disposition Comment:
Disposition Date: 01 JAN 1960
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Decument Number: 1076TOW

Document Number: 1976TOKYO02595
Document Source: CORE
Document Unique ID: 00

Drafter: n/a Enclosure: n/a Executive Order: N/A Errors: N/A

Film Number: D760066-0921

From: TOKYO

Handling Restrictions: n/a

Image Path:

Legacy Key: link1976/newtext/t19760222/aaaaasxg.tel Line Count: 48

Locator: TEXT ON-LINE, ON MICROFILM Office: ACTION COME Original Classification: UNCLASSIFIED Original Handling Restrictions: n/a Original Previous Classification: n/a Original Previous Handling Restrictions: n/a

Page Count: 1

Previous Channel Indicators: n/a
Previous Classification: n/a Previous Handling Restrictions: n/a Reference: n/a

Review Action: RELEASED, APPROVED
Review Authority: castelsl

Review Comment: n/a Review Content Flags: Review Date: 09 JUL 2004

Review Event:

Review Exemptions: n/a
Review History: RELEASED <09 JUL 2004 by schwenja>; APPROVED <25 AUG 2004 by castelsl>

Review Markings:

Margaret P. Grafeld Declassified/Released US Department of State EO Systematic Review 04 MÁY 2006

Review Media Identifier: Review Referrals: n/a Review Release Date: n/a Review Release Event: n/a **Review Transfer Date:** Review Withdrawn Fields: n/a

Secure: OPEN Status: NATIVE

Subject: PROPOSED VISIT OF JAPANESE STUDY GROUP TO U.S. PATENT OFFICE

TAGS: EGEN, JA, US To: STATE

Markings: Margaret P. Grafeld Declassified/Released US Department of State EO Systematic Review 04 MAY 2006